

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Cha Deok DONG

Application No.: 10/720,457

Confirmation No.: 4077

Filed: November 24, 2003

Art Unit: 2822

For: METHOD FOR FORMING DEVICE
ISOLATION FILM IN SEMICONDUCTOR
DEVICE

Examiner: Michael M. Trinh

AMENDMENT "B"

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the official action dated April 18, 2007, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.